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1. DESIGN APPLICATIONS  
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JAPAN 2005-335234 11/22/2005  
JAPAN 2005-112110 08/16/2005  
JAPAN 2001-311011 02/28/2001  
JAPAN 2001-316558 07/03/2001  
JAPAN 2001-333399 07/03/2001  
JAPAN 2001-335301 07/15/2001  
JAPAN 2001-155862 01/15/2001  
JAPAN 2001-182041 03/05/2001  
JAPAN 2001-182042 03/05/2001

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aspiration system by charged particle beam and method of manufacturing devices using the system